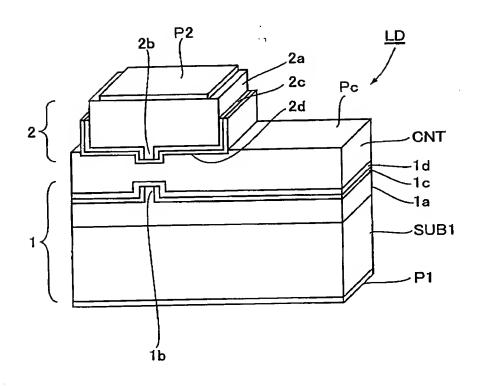
Title: METHOD FOR FABRICATING SEMICONDUCTOR LASER DEVICE Inventor: Mamoru MIYACHI et al. Appln. No.: New Application Docket No.: 107156-00333

FIG.1



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FIG.2 (a) FIG.2 (b) CNT1 1Ъ 1b 2b CNT2 2d 2c Y2a SUB1 SUB2 FIG.2 (c) FIG.2 (d) LASER BEAM SUB2 SUB2 CNT2 Y2a 2b

100

FIG.2 (e)

SUB1

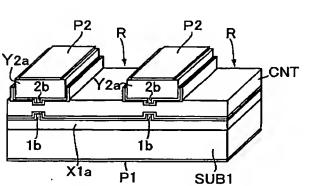


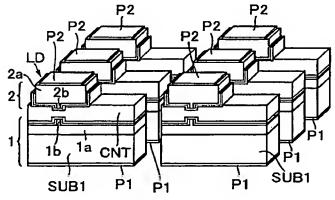
FIG.2 (f)

100

SUB1

X1a

CNT

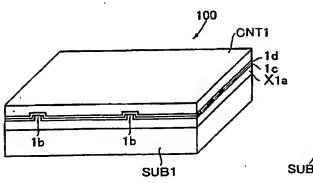


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FIG.3 (a)

FIG.3 (b)



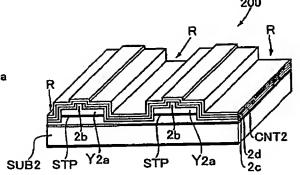
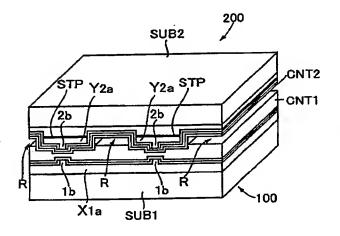


FIG.3 (c)

FIG.3 (d)



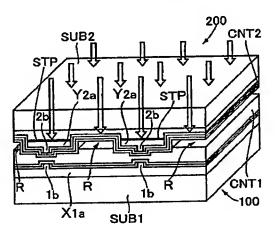
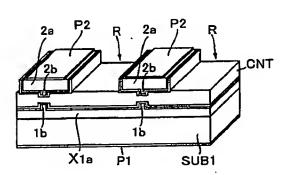
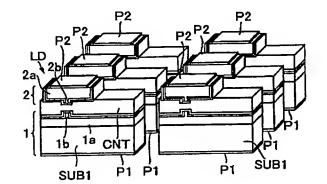


FIG.3 (e)

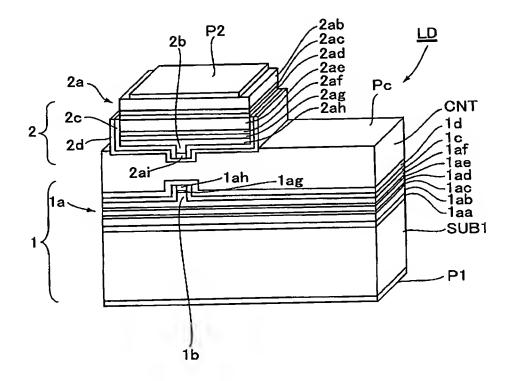
FIG.3 (f)





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FIG.4



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FIG.5 (a)

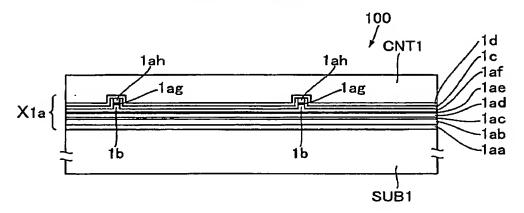
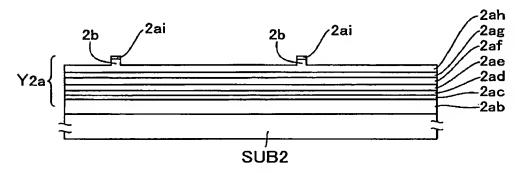
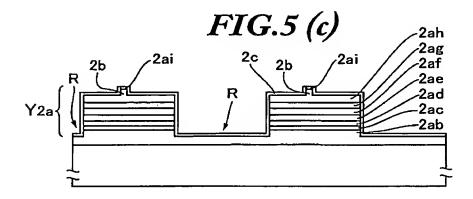
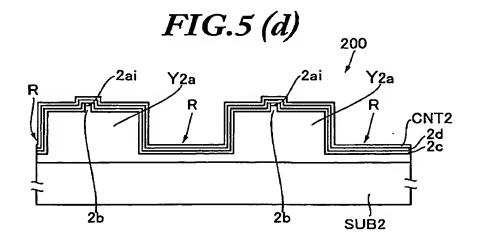


FIG.5 (b)







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FIG.6 (a)

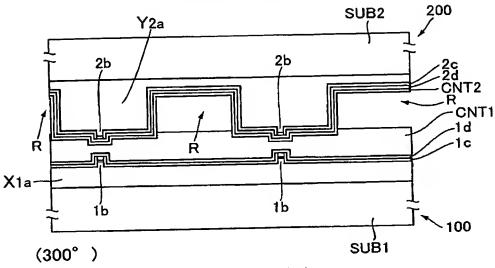


FIG.6 (b)

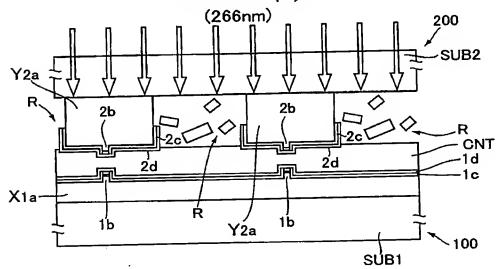
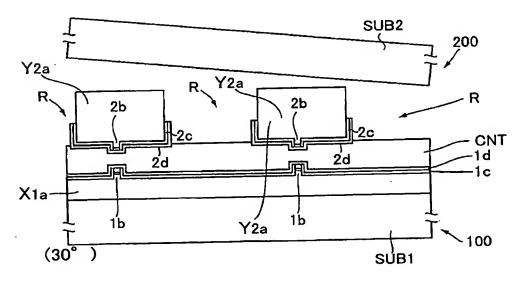


FIG.6 (c)



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FIG.7 (a)

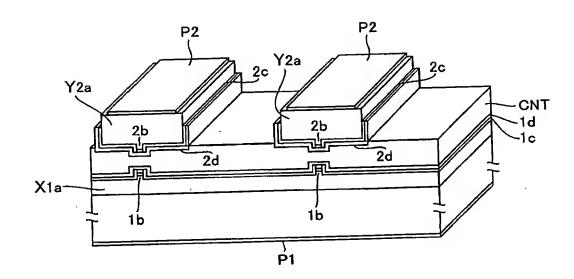
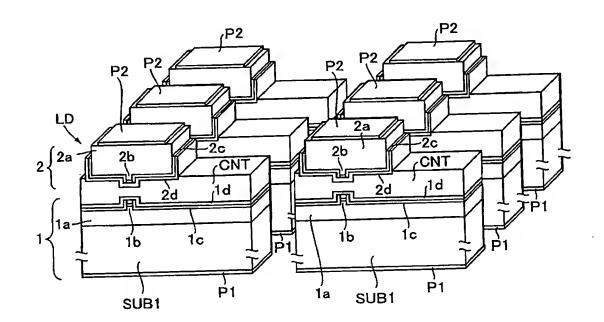


FIG.7 (b)



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FIG.8 (a)

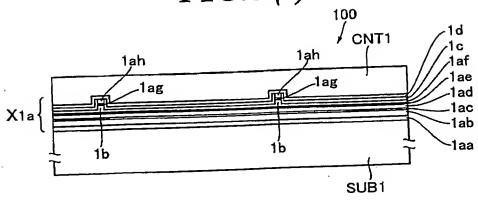


FIG.8 (b)

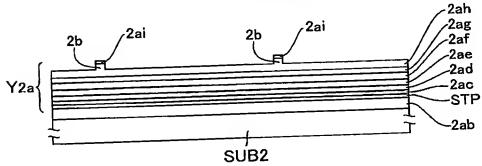


FIG.8 (c)

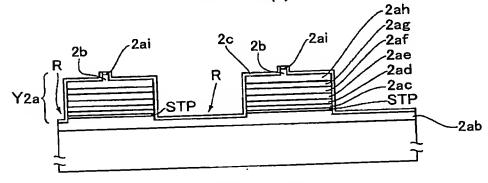
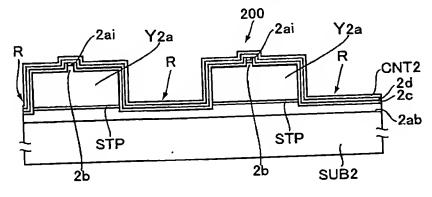


FIG.8 (d)



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FIG.9 (a)

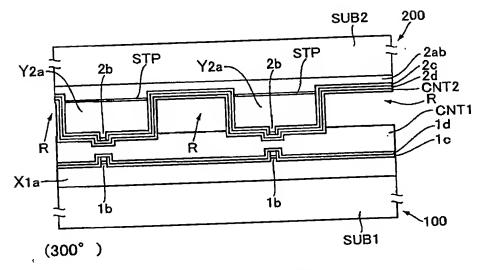


FIG.9 (b)

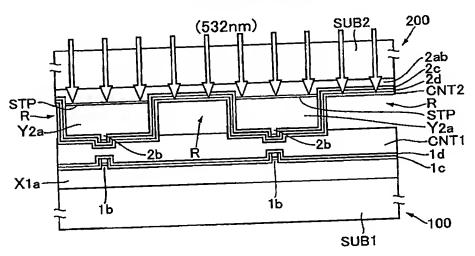
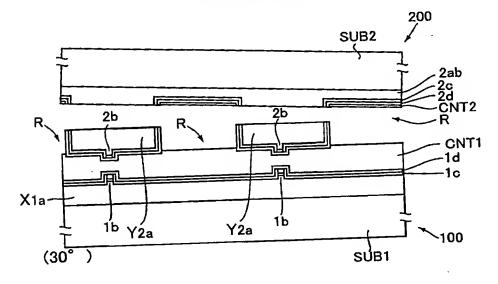


FIG.9 (c)



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FIG.10 (a)

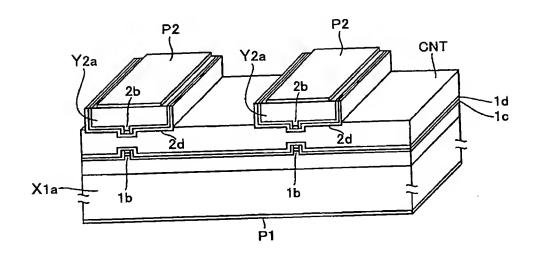


FIG.10 (b)

